Docker No.

0 6 2003

210313US2SRD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TECHNOLOGY CENTER 2800

APPLICATION OF: Akira NISHIYAMA, et al.

SERIAL NO: 09/891,129

GAU: 2814

RCE FILED: Herewith

EXAMINER: Mai, A.

FOR:

SEMICONDUCTOR DEVICE HAVING AN INSULATING FILM MADE OF A HIGHLY DIELECTRIC

THIN FILM AND METHOD OF MANUFACTURING THE SAME

REQUEST FOR EXTENSION OF TIME **UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a two month extension of time be granted to June 14, 2003 for

filing a response to the Official Action dated:

responding to the requirements in the Notice of Allowability dated:

filing the Formal Drawings. The Issue Fee due

has been timely filed.

responding to the Notice to File Missing Parts of Application dated:

filing an Amendment concurrently with an RCE. A timely response to the final rejection, due April 14, 2003 has

been filed.

filing an Appeal Brief. A Notice of Appeal was filed on:

Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by

one-half.

The required fee of \$410.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Gregory J. Maier

Registration No. 25,599

Surinder Sachar

Registration No. 34,423

Tel. (703) 413-3000 Fax. (703) 413-2220

(OSMMN 05/03) I:\ATTY\SNS\21's\210313\EOT2.DOC

06/09/2003 WABRHAM1 00000051 09891129

02 FC:1252

410.00 DP